- IPE	<u>, </u>				IN
TRANSMITTAL LETTER (General - Patent Pending)				Docket No. YOR920030526US1 (17107)	
In the Application of TRADE	f: Stephen W. Bede	ell, et al.			
Application No. 10/728,519	Filing Date 12/5/2003	Examiner Dang, Phuc T.	Customer No. 23389	Group Art Unit 2818	Confirmation No 9033
Title: METHOD	OF FABRICATING S	STRAINED SI SOI WAFERS			
COMMISSIONER FOR PATENTS:					
Authorization To	nge of Mailing Addres Act In a Representati			·	
in the above identif	ied application.				
☐ A check in the ☐ The Director as described ☐ Cha☐ Crec ☐ Cha☐ ☐ Payment by cowarning: I	I below. rge the amount of dit any overpayment. rge any additional fee credit card. Form PTO nformation on this		redit card infor authorization o	on PTO-2038.	not be
<i>U</i>	Signature		Dated: Marc	eh 30, 2005	

Leslie S. Szivos, Ph.D. Registration No. 39,394

CC:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

March 30, 2005

(Date)

Signature Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

applicant(s): Stephen W. Bedell, et al.

Docket: YOR920030526US1 (17107)

Serial No:

10/728,519

Date:

Filed:

December 5, 2003

For: METHOD OF FABRICATING STRAINED Si SOI WAFERS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AUTHORIZATION TO ACT IN A REPRESENTATIVE CAPACITY

Sir:

The practitioner named below is authorized to conduct interviews and has the authority to bind the principal concerned. Furthermore, the practitioner is authorized to file correspondence in the above-identified application pursuant to 37 C.F.R. §1.34:

FRANK S. DIGIGLIO, Reg. No. 31,346; LEOPOLD PRESSER, Reg. No. 19,827; STEVEN FISCHMAN, Reg. No. 34,594; JOHN S. SENSNY, Reg. No. 28,757; EDWARD W. GROLZ, Reg. No. 33,705; LESLIE S. SZIVOS, Reg. No. 39,394; and WILLIAM C. ROCH, Reg. No. 24,972.

This is not a Power of Attorney to the above-named practitioner(s). Accordingly, the practitioner(s) named above do(es) not have authority to sign a request to change the correspondence address, a request for an express abandonment, a disclaimer, a power of attorney, or other document requiring the signature of the applicant, assignee of the entire interest or an attorney of record. If appropriate, a separate Power of Attorney to the above-named practitioner(s) should be executed and filed in the United States Patent and Trademark Office.

Respectfully submitted:

Registration No. 25

International Business Machines Corporation Intellectual Property Law Dept. 1101 Kitchawan Road, Route 134 P.O. Box 218 Yorktown Heights, New York 10598 (914) 945-3147



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REQUEST FOR CHANGE OF MAILING ADDRESS

Sir:

Applicant(s) request(s) that all future correspondence in connection with this application be directed and addressed to:

STEVEN FISCHMAN, ESQ. SCULLY, SCOTT, MURPHY AND PRESSER 400 Garden City Plaza Garden City, New York 11530 Direct all telephone calls to: (516) 742-4343.

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